RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP: 2879

Patent

Case No.: 58429US002

32692 Customer Number

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor:

YOKOYAMA, CHIKAFUMI

Application No.:

10/698200

Confirmation No.:

9988

Filed:

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Title:

METHOD OF FORMING MICROSTRUCTURES ON A SUBSTRATE AND A

MICROSTRUCTURED ASSEMBLY USED FOR SAME

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This is in response to the outstanding Office Action, dated February 23, 2007, in the above-identified application.

